

10/567792

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuyoshi NAKATSUKASA et al.**

Serial Number: **Not yet assigned**

(§371 of International Application No. PCT/JP2003/015431)

Filed: **February 9, 2006**

For: **METHOD OF PROCESSING SUBSTRATE AND SUBSTRATE
PROCESSING APPARATUS**

Attorney Docket Number: **062032**

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

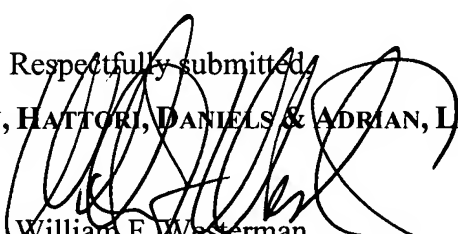
February 9, 2006

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non- U.S. document is enclosed herewith.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,
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Enclosure: PTO/SB/08, 5 documents and international search report.

Combined Form PTO/SB/08A&B <u>INFORMATION DISCLOSURE</u> <u>STATEMENT BY APPLICANT</u> <i>(use as many sheets as necessary)</i>				<i>Complete if Known</i>	
				Application Number	
				Confirmation Number	
				Filing Date	
				First Named Inventor	
				Art Unit	
Examiner Name				Attorney Docket Number	
Sheet 1 of 1				062032	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ³ (if known)		
		US			
		US			
		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
	1	JP	2000-55543		02-25-2000	Tokyo Electron, Ltd.	Abstract, cited in the ISR
	2	JP	2002-134461		05-10-2002	Sony Corp.	Abstract, cited in the ISR
	3	JP	10-118586		05-12-1998	Komatsu Ltd.	Abstract, cited in the ISR
	4	JP	11-191549		07-13-1999	Dainippon Screen Mfg, Co., Ltd.	Abstract, cited in the ISR
	5	JP	2002-359221		12-13-2002	M FSI KK	Abstract, cited in the ISR

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
	6	International Search Report, dated February 24, 2004 of PCT/JP2003/015431	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.